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Title: Resolution enhancement techniques for optical lithography and optical imaging theory: Authors: Shibuya, Masato: Affiliation: AA(Optical Designing Headquarters
<http://adsabs.harvard.edu/abs/1997OptRv...4..151S>

Jun 30, 2011 Different resolution enhancement techniques for lithography 01 Jul. So, imaging close to the resolution limit of the optical system,
<https://nanoravi.wordpress.com/2011/07/01/different-resolution-enhancement-techniques-for-lithography/>

Lars W. Liebmann "Resolution enhancement techniques in optical lithography: It's not just a mask problem", Proc. SPIE 4409, Photomask and Next-Generation Lithography
<http://proceedings.spiedigitallibrary.org/proceeding.aspx?articleid=883912>

Steven R. J. Brueck and Xiaolan Chen "Spatial frequency analysis of optical lithography resolution enhancement techniques", Proc. SPIE 3679, Optical Microlithography
<http://proceedings.spiedigitallibrary.org/proceeding.aspx?articleid=984458>

University of Texas at Austin Digital Repository Design and development of material-based resolution enhancement techniques for optical lithography
<http://repositories.lib.utexas.edu/handle/2152/22248>

With the adoption of various combinations of resolution enhancement techniques (RET) for IC lithography, different process constraints are placed on the IC layout.
<http://citeseerx.ist.psu.edu/showciting?cid=819941>

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forcing semiconductor manufacturers to extend the current 193 nm optical lithography systems The combined techniques include Resolution Enhancement
http://en.wikipedia.org/wiki/Computational_lithography

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<http://www.dlzware.com/to/spie>

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Mutually Optimizing Resolution Enhancement Techniques: Illumination, APSM, Assist Feature OPC, and Gray Bars Proc. SPIE Optical Microlithography XIII,

http://www.rit.edu/~w-lith/research/imagetheory/SPIE_2001_4348-48.pdf

Digital resolution enhancement in surface plasmon resolution of optical microscopy and of the optical system. One of such techniques is matrix

<http://arxiv.org/pdf/physics/0512156.pdf>

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Resolution enhancement technologies are methods is known as Optical are usually grouped under the heading resolution enhancement techniques

http://en.wikipedia.org/wiki/Resolution_enhancement_technologies

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<http://link.springer.com/article/10.1007%2F02936016>

We survey the history of resolution enhancement techniques the exciting modern developments that provide resolution enhancement techniques in optical microscopy.

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The Design of Plastic Optical Systems Michael P. Schaub Author(s): Larry C. Andrews,

<http://www.yzu.edu.tw/library/files/text/SPIEebookslist.xls>